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# Three-dimensional selfassembly of millimetrescale components

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The spontaneous association of molecules, termed molecular selfassembly, is a successful strategy for the generation of large, structured molecular aggregates<sup>1</sup>. The most important source of inspiration for this strategy is the biological world, in which many processes involve interfacial interactions and shape selectivity that guide the formation of complex, multicomponent threedimensional structures. The success of molecular self-assembly notwithstanding, many objectives in science and technology require the assembly of components that are much larger than molecules: examples include microelectronic and microelectromechanical systems, sensors and microanalytical and microsynthetic devices<sup>2</sup>. Photolithography, the principal technique used to make such microstructures, has certain limitations: it cannot easily form non-planar or three-dimensional structures; it generates structures that are metastable; and it can be used only for a limited set of materials<sup>3</sup>. Here we describe an approach for the self-assembly of millimetre-scale components that uses two concepts to direct the assembly process: shape recognition and the minimization of liquid-liquid interfacial free energies<sup>4</sup>. These play a role in other spontaneous self-assembly phenomena, such as the formation of bubble rafts<sup>5,6</sup>, the patterned dewetting of surfaces<sup>7,8</sup>, and the coalescence of liquid drops<sup>9</sup>. We apply selfassembled monolayer molecular films<sup>10</sup> to the surfaces of shaped macroscopic objects to render them hydrophilic or hydrophobic. depending on the terminal groups of the bound molecules. In aqueous solution, hydrophobic surfaces bearing a thin film of a

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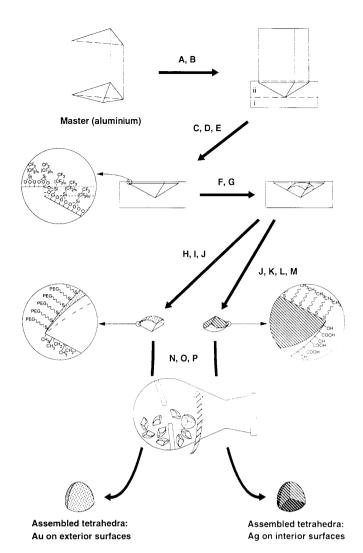


Figure 1 Schematic outline of the process used to fabricate and assemble components of the tetrahedra. The master (top left) was fabricated from aluminium by machining; the angles defining the edges at the tip were 109°. Process steps are as follows: (A) A pad of polydimethylsiloxane (PDMS, i) was cast and cured. (B) The master was cast into a second layer (ii) of PDMS. (C) After curing, the master was removed. (D) This PDMS mould was oxidized in an oxygen plasma to generate surface Si-OH groups. (E) Exposure to perfluoroalkyl trichlorosilane vapour resulted in the formation of a perfluoroalkylated surface (see inset). (F) A measured amount of the liquid poryurethane prepolymer was added by means of a syringe pump and (G) was cured in ultraviolet light. (H) Gold was evaporated on top of the parts while they remained in the mould. (I) A hydrophilic self-assembling monolaver was formed on the dord surface by immersion in a solution of a thiol terminating in boll, etcl, energised (PEG) groups (the PEG used was methoxy-terminated material with molecular weight 350); this thiolate is The parts were removed from the mould. hydrophilic and resists addres to u (K) Stylendias evant traded in the port importme parts. (L) The parts were oxidized in an okugan plasma. MilliAn uprior to ose flassembling monolayer was generated th the Abis of about interversion of the parts in a solution of CH3(CH2)15SH. (N) A number of carts (typical), 20-100) were placed in the assembly flask and the liquid agnesive and ethanol were added and distributed. (O) Water was added until the flask was completely filled, and the mixture was rotated mechanically for several hours; the tetrahedra assembled themselves. (P) If the glue was photocurable, the parts 'froze' into place on ultraviolet irradiation. They were then removed and examined.

hydrophobic, lubricating liquid adhere to similar surfaces with complementary shapes, while being able to adjust their relative alignment to ensure a good fit. In this way, the components assemble into well defined aggregates, which can be bound permanently when the hydrophobic liquid films consist of a polymerizable adhesive.

Figure 1 outlines our process. The individual components to be assembled were formed from a hydrophobic polymer (typically a polyurethane: NOA-63 or NOA-88; Norland, New Brunswick, NJ) by moulding. The surface of these components was patterned into hydrophilic and hydrophobic regions using two procedures. In one, some portions of the surface were covered (often by leaving the units in the moulds in which they were made), and the exposed surfaces were oxidized with an oxygen plasma. This process left the hidden surfaces hydrophobic, while making the exposed surfaces hydrophilic. In a second, differentiation was achieved by coating the regions with gold or silver by evaporation, and assembling monolavers of hydrophobic or hydrophilic<sup>10</sup> thiols onto them. The components were placed in a flask, their surface was wetted with ethanol, a small amount  $(0.05-0.1 \,\mu l \text{ per mm}^2 \text{ of hydrophobic})$ surface) of a hydrophobic liquid-either an alkane or a photopolymerizable adhesive, such as dodecyl methacrylate—was added, and the system was stirred gently to coat the surfaces. Water was added; the water displaced the hydrophobic liquid from the hydrophilic surfaces, while leaving a thin film of liquid coating the hydrophobic surfaces. The aqueous suspension of the components was tumbled in a rotating flask. This agitation brought the components into contact. The hydrophilic surfaces stuck neither to other hydrophilic surfaces nor to the hydrophobic surfaces with their thin coating of liquid, whereas the hydrophobic surfaces adhered to one another. Once the surfaces were in contact, the liquid acted as a lubricant, allowing the components to adjust their position relative to one another by lateral movement. This movement minimized the interfacial free energy of the system by minimizing the surface area of the lubricant–water interface. After the systems had approached equilibrium, ultraviolet irradiation (when the liquid was a photopolymerizable adhesive) 'froze' the assembly into permanent form. These components were removed and examined.

Figure 2 shows small assemblies fabricated using this procedure. The most complicated of the structures formed was approximately a sphere: four pieces with hydrophobic faces defined by planes meeting at the tetrahedral angle (109°) were the components that assembled. A key component to these assemblies was to make the contacting surfaces smooth; if they were rough, the lateral motion required to reach the configuration with the maximum contacting surface was hindered by direct, unlubricated contact and adhesion of the surfaces. To generate suitably smooth surfaces, the faces of the aluminium master were polished to a mirror finish; we did not measure the surface roughness.

The assemblies in Fig. 2a-c are symmetrical. It was also possible to generate unsymmetrical assemblies by taking advantage of docking of unsymmetrical components using shape-selective recognition; Fig. 2d is a demonstration of the principle. The assembly of complementary shapes is integral to the formation of most

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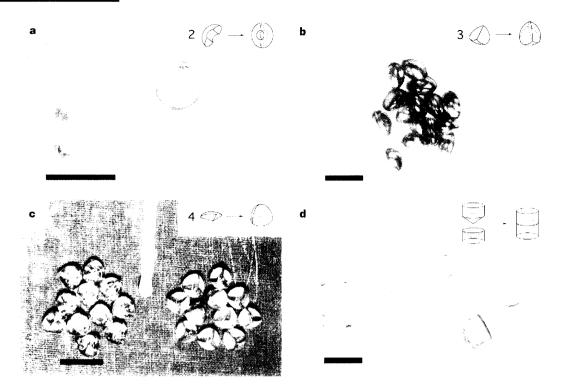


Figure 2 Several examples of self-assembled structures. Scale bars, 1 cm. **a**, Two arches ione of them at the left) form small 'doughnuts'. The differentiation was achieved in this case of px dation of the outer sides, while the achering surfaces were unmodified in prophodic both umer. NOA-63: **b**, Small to total sitement from three identical carts. The aches were unmodified of umer. NOA-63: **b**, Small to total sitement from three identical carts. The aches were unmodified of umer. NOA-63: **b**, Small to total sitement from three identical carts. The aches were unmodified of umer. NOA-63: **b**, Small to total sitement from three identical carts. The aches were unmodified of umer. NOA-63: **b**, Small to total sitement from three identical carts. The aches were unmodified of umer. NOA-63: **b**, Small to total sitement from three identical carts. The aches is solved upmodified of umer. NOA-63: **b**, Small to total sitement from three identical carts. The aches is solved upmodified of umer. NOA-63: **b**, Small to total sitement from three identical carts. The aches is solved upmodified of umer. NOA-63: **b**, Small to total sitement from three identical carts. The aches is solved upmodified of upmer. NOA-63: **b**, Small to total sitement is carts, and show the curved outer surface was a 20-6 method. A write a set is solved upmer of a cart set is a carts of the curved outer surface was a 20-6 method. A write a set is set is set in a set is set in a set is set is set in a set is set is set in a s

parts. The surface treatment for the objects on the left was as in **b** (gold on the exterior faces, see also Fig. 1). On the right, the adhesive, interior sides of the tetrahedral were concered with a hydrophobic self-assembling monolayer. Chino Sections which a hydrophobic self-assembling monolayer. This control that is a concern to use the subscript subscript set of the subscript share the interior surfaces. **d**, Two other structures assembled to a concern manner. The achering surfaces were unit to face other sides were made hydrophilic by treatment with an exigen plasma (see Fig. 1 for details of surface processing).

complex biological systems. Our demonstration indicates that the same strategy can be applied to non-biological assemblies.

This work establishes that shape-selective recognition of surfaces and minimization of interfacial free energies can be combined to provide a strategy for assembling small components into threedimensional assemblies. Because association is reversible, the system is self-repairing; the experiments described here usually result in quantitative formation of correctly assembled objects. We believe that we will be able to assemble smaller structures using the same or a similar methodology, and that we will be able to build functional devices.

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